

## Supporting Information

### Physical and electrical characterization of bubble free transferred single crystal graphene

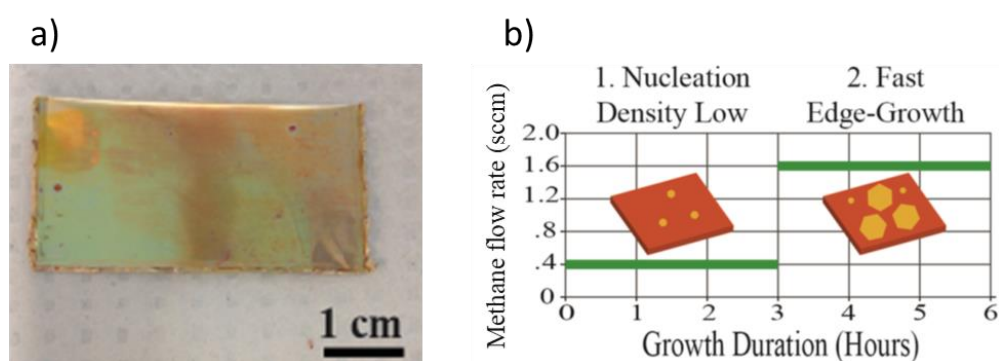


Fig S1: (a) Optical image of the copper foil folded in half, the remaining three sides being carefully crimped to obtain an enclosed pocket (b) Illustration of the two-step growth process of the graphene monocrystals.

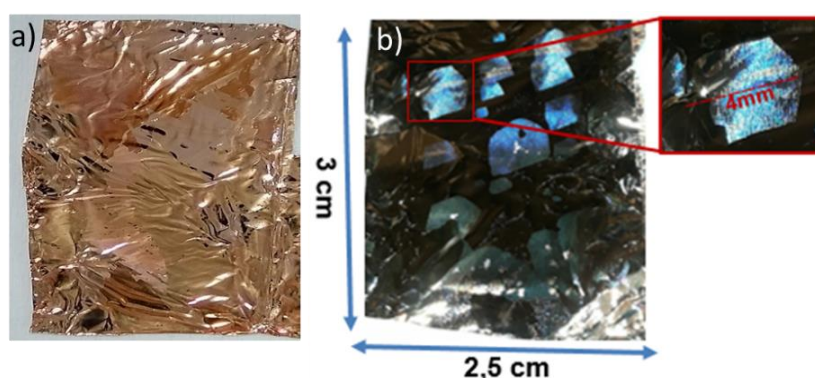


Fig S2: Unfolded copper pocket, inside face, after growing graphene monocrystals (a) optical image of the Cu foil without flashlight and (b) with flashlight that helps to visualize the large crystals grown on the top.

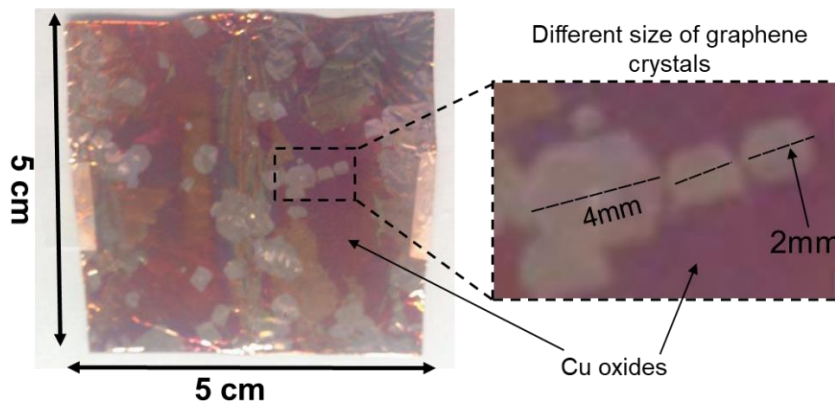


Fig S3 : Optical image of graphene nanocrystals on copper foil after post-growth annealing. The resulting oxidation of copper makes individual crystals visible by eyes.

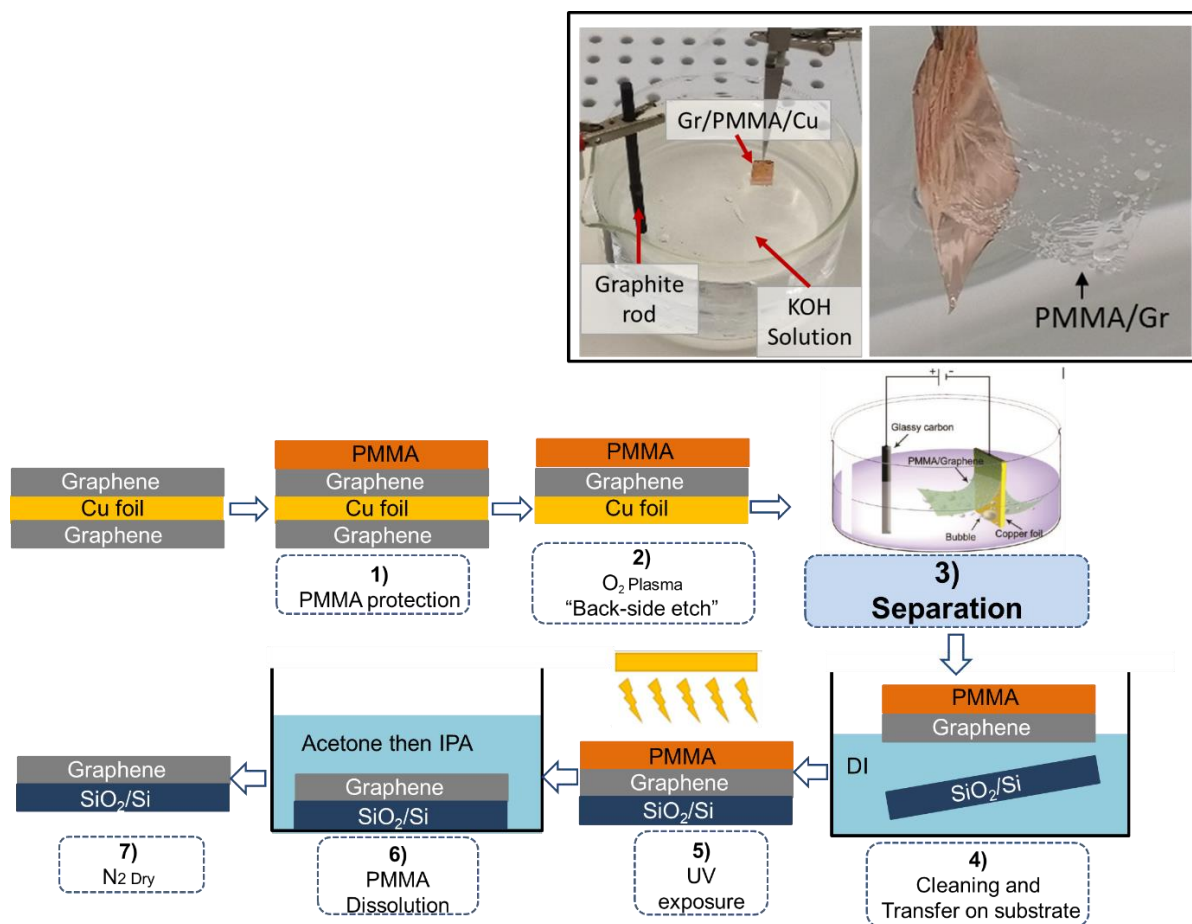


Figure S4: Procedure of graphene transfer to a host substrate using the electrochemical delamination transfer method.

The electrochemical delamination transfer method consists of seven steps as described below:

**Step 1: Protection of graphene with a layer of PMMA**

The synthesized graphene on copper foil is spincoated with PMMA 5% 950K.

**Step 2: Etching of graphene on the backside of the copper foil by oxygen plasma**

O<sub>2</sub> Plasma etching parameters: 50W, 100mTorr, 25sccm. (Reactive Ion Etching)

**Step 3: Electrochemical delamination of graphene from the copper foil (see details in the next paragraph)**

**Step 4: Graphene cleaning and transfer**

After separating graphene from growth substrate, the film PMMA/Graphene is floating on the solution surface. It is then rinsed in dionised water many times then transferred on Si/SiO<sub>2</sub> substrate. In order to remove water at the interface between graphene and the substrate, the sample is baked at 90°C.

**Step 5: Exposure of the sample to UV light**

Deep UV during 30 min at 500W in order to facilitate PMMA removal as well as its residues.

**Step 6: Dissolution of PMMA**

Acetone bath for 30 min at 30-35°C followed by IPA bath.

**Step 7: Drying gently with nitrogen flow**

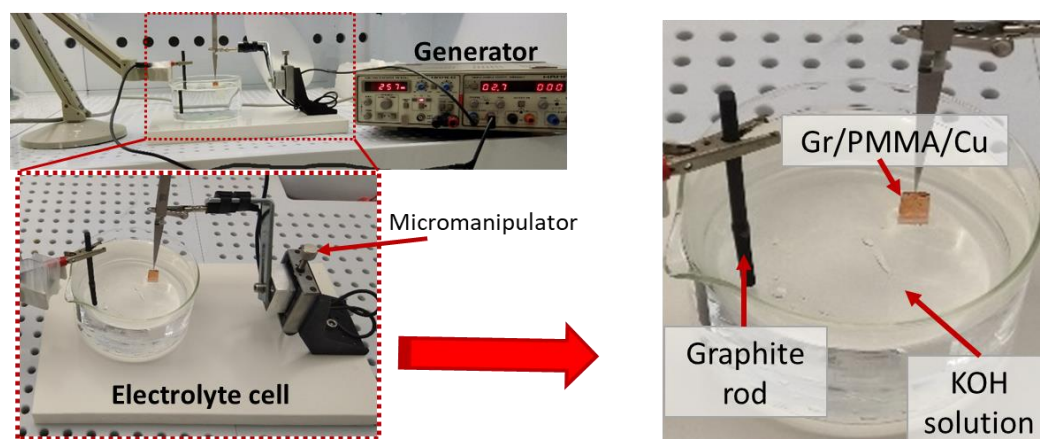


Fig S5: Experimental setup for electrochemical delamination of graphene.

### Optimization of the delamination process

We first looked for the optimal voltage allowing the separation of graphene from the copper foil while generating the minimum amount of hydrogen bubbles. The distance between the electrodes was fixed (7 cm), using a clean grassy carbon counter electrode, and a standard electrolyte solution (0.2 mol/L KOH). We started with the higher applied bias and gradually went to lower bias. When the applied bias was higher than 4V, vigorous hydrogen bubbles were appearing which causes the graphene/PMMA film to roll on itself during separation. By decreasing the applied bias, the separation of graphene from copper foil is still observed when the applied bias was 3V (Fig S6-I (c)), but no reaction takes place when applied bias was 2V Fig S6-I (d). By empirically varying the voltage value between 2V and 3V until the graphene begins to detach from the copper, we concluded that 2.7V is the minimum voltage that allows separation of graphene from copper while generating the minimum amount of hydrogen bubbles in our system.

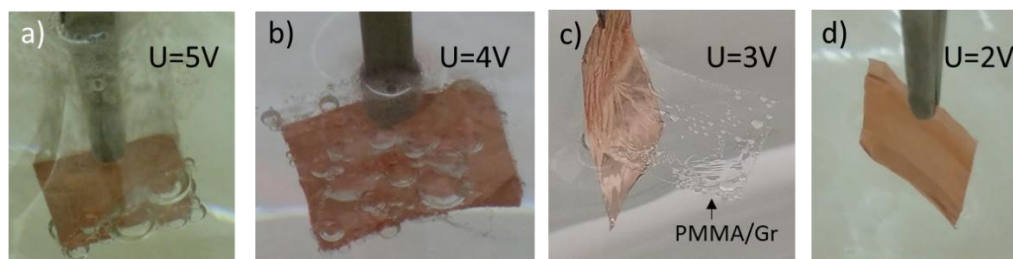


Fig S6-I: Effect of the applied voltage on H<sub>2</sub> bubbles generated during transfer (a) vigorous flow for 5V (b) fewer bubbles for 4V (c) almost no bubbles for 3V and (d) no bubbles but no reaction at 2V.

Considering the optimal obtained voltage (2.7V) for graphene separation from the Cu substrate, next we varied the concentration of the electrolyte. In a volume of 500 ml deionized water (DI), the KOH solution (40%) was added by amounts of 0.5 ml (the concentration of the stock solution is 7140 mmol/L) until graphene begins to detach from copper. An optimum of 42 mmol/L (3ml of KOH (40%) in 500ml of DI) is obtained for a 2.7V allowing a transfer without defects and with the minimum contamination. The fig S6-II (a) shows the PMMA / graphene film floating on the surface of the solution without the presence of bubbles trapped under the film. The same film is shown just after transfer on SiO<sub>2</sub> (c) and after annealing (d). The film is homogeneous and does not feature any folds or tears.

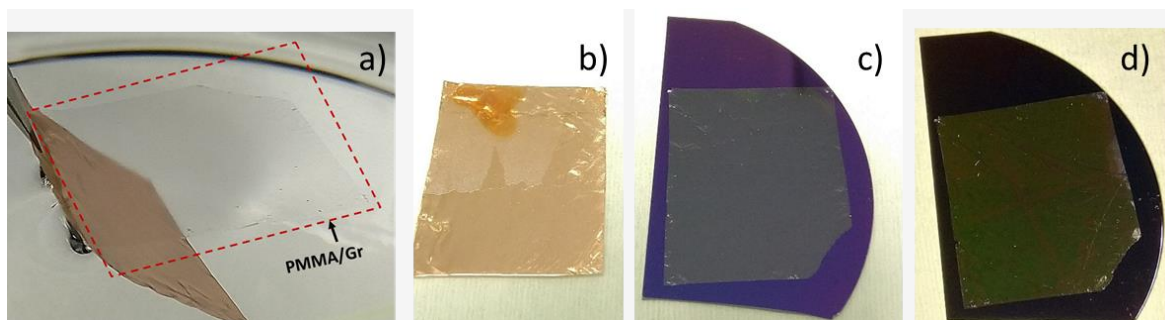


Fig S6-II: transfer using optimal parameters (2.7 V, 42 mmol/L) showing the PMMA/Graphene film (a) during the separation from copper (b) on copper (c) on SiO<sub>2</sub> before annealing (d) on SiO<sub>2</sub> after annealing.